



FPD Materials & Components Japan TC Chapter

Japan Standards Fall 2022 Meetings
Friday, October 14, 2022,
OVTCCM/ SEMI Japan Office (Hybrid)
14:30-16:30[JST]

SVM Software (for voting) * Please also log in to SVM.

1. Open a Web browser and go to: <https://svm.semi.org/> (Do not use Internet Explorer or MS Edge)
2. Click "Login"
3. Enter your Standards Membership username and password (same login for voting on ballots).
1. If you have forgotten your username and/or password, they may be retrieved at: <https://ams.semi.org/ebusiness/ForgotUID.aspx>
2. Find the meeting room: < FPD Materials & Components Japan TC Chapter Meeting Oct.14,2022>
3. Click "Go"

AGENDA

1.0 Welcome / Call to Order

- 1.1 Introductions
- 1.2 Meeting Reminders (*Membership Requirement, Antitrust and Intellectual Property Reminders, Effective Meeting Guidelines*)
- 1.3 Agenda Review

2.0 Review of Previous Meeting Minutes

3.0 Liaison Report

- 3.1 FPD Metrology Korea TC Chapter
- 3.2 FPD Metrology Taiwan TC Chapter

4.0 Staff Report

5.0 Ballot Review

- 5.1 6988, Revision to SEMI D6-0211 (Reapproved 0117) "Specification For Liquid Crystal Display (LCD) Mask Substrates" with title change to "Specification For Flat Panel Display (FPD) Mask Substrates"
- 5.2 6989, Revision to SEMI D38-0211 (Reapproved 0117) "Guide For Quality Area Of LCD Masks" with title change to "Guide For Quality Area Of Flat Panel Display (FPD) Masks"
- 5.3 6912, Line Item Revision to SEMI D39-0704 (Reapproved 0117): "SPECIFICATION FOR MARKERS ON FPD POLARIZING FILMS"
- 5.4 6937. New Standard: TERMINOLOGY FOR FPD PHASE SHIFT MASK AND MASK BLANKS

6.0 Subcommittee & Task Force Reports

- 6.1 Flexible Display TF
- 6.2 FPD Mask TF
- 6.3 FPD Materials & Components Maintenance TF

7.0 Old Business

- 7.1 Project Period Review
- 7.2 5-Year Review
- 7.2.1

8.0 New Business

- 8.1 Proposal of New Activity

9.0 Action Item Review

- 9.1 Open Action Items
- 9.2 New Action Items

10.0 Next Meeting and Adjournment